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|  |  |  | 16/01 2015 |
|  | Journalnr.: | Enhed: | Initialer |
|  | Undervisningsplan (foreløbig), Hitachi skanning elektron mikroskop |
|  | Tirsdag den 20. januar – torsdag den 22. januar 2015 |

Day 1 - with Sten Sturefelt

09:00 - 09:30: Arrival. Checking the lab, the microscope, computer access, sample preparation facilities, etc. Setting up in the meeting room.

09:30 - 11:30: Introduction to scanning electron microscopy, including coffee break and questions. Splitting into smaller groups.

11:30 - 12:30: Lunch

12:30 - 15:30: Group 1 - Sample preparation, introduction to using S-3400N, coffee, participants’ supervised practical exercises, questions.

Day 2 - with Sten Sturefelt

09.00 - 12.00: Group 2 - Sample preparation, introduction to using S-3400N, coffee, participants’ supervised practical exercises, questions.

12.00 - 13.00: Lunch

13.00 - 16.00: Group 1&2 – Backup time, questions, repetition and work with participants’ own samples.

Day 3 - In depth training - focus on the EDS system, with Mats Eriksson

09:00 - 11.30: Joint session in a meeting room

11:30 - 12:30: Lunch

12:30 - 14:00: Practicals, group 1

14:30 - 15:00: Break

15:00 - 16:30: Practicals, group 2